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				Application Number		
INFO	ORMATION	N DISCLO	SURE	Filing Date		
STA	STATEMENT BY APPLICANT (Use as many sheets as necessary)			First Named Inventor	Dingjun Wu, et al.	
				Art Unit		
				Examiner Name		
Sheet	1	of	2	Attorney Docket Number	06457 USA	

			U. S. PATENT DO	CUMENTS	
Examiner Initials*	Cite No.1	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or
		Number-Kind Code ^{2 (f known)}			Relevant Figures Appear
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Examiner Initials*	Cite No.1	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or			
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		JP 61-106780		Japan (abstract)				

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Su	bstitute for form 14	149/PTO		Complete if Known		
		. D.O.O.	01105	Application Number		
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	STATEMENT BY APPLICANT (Use as many sheets as necessary)			First Named Inventor	Dingjun Wu, et al.	
				Art Unit		
				Examiner Name		
Sheet	2	of	2	Attorney Docket Number	06457 USA	

		NON PATENT LITERATURE DOCUMENTS	
Examiner Initials*	Cite No. 1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
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